

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10642750	FUJITA ET AL.
	Examiner	Art Unit
	Keefer, Michael E	2454

SEARCHED

Class	Subclass	Date	Examiner
709	244 (Updated 4/23/2009)	12/11/2006	MEK

SEARCH NOTES

Search Notes	Date	Examiner
EAST Search	12/11/2006	MEK
Consulted Examiner Kevin Bates	5/5/2008	MEK
Consulted Primary Examiner Dustin Nguyen	4/23/2009	MEK
Google Search	4/27/2009	MEK
IEEE Search	4/27/2009	MEK

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
709	244	4/23/2009	MEK

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